

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Woo Sik Yoo

Assignee:

WaferMasters, Inc.

Title:

Gas-Assisted Rapid Thermal Processing

Serial No.:

10/005,827

Filing Date:

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Examiner:

Trinh, Michael Manh

Group Art Unit:

2822

Docket No.:

M-11914 US

Irvine, California November 24, 2004

Mail Stop Issue Fee COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT UNDER 37 C.F.R. § 1.312

Dear Sir:

Pursuant to 37 C.F.R. § 1.312, Applicants respectfully request the Examiner to enter the following amendments in the above-identified application.

## IN THE DRAWINGS

Please replace sheets 1 and 2 of the previously submitted formal drawings.

Replacement sheets 1 and 2 are enclosed with this document.

## **REMARKS**

Pursuant to 37 C.F.R. §1.312, Applicants request entry of the above amendments, which are being filed together with the payment of the issue fee. Applicants have amended the drawings and are submitting replacement sheets as per the Examiner's request.

Direct 51/2/02

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